

Attorney Docket :  
033082M115



P A T E N T

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**CONFIRMATION NO. 3236**

In re the application of:	)	
	)	
<b>Takayuki TOSHIMA, et al.</b>	)	
	)	
Serial No. : 10/052,534	)	Art Unit : 1746
	)	
Filed : January 23, 2002	)	Examiner : Michail KORNAKOV
For : Substrate Processing Apparatus and Substrate Processing Method		

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

A response to the Office Action dated October 8, 2004 was due by January 8, 2005. A Petition for Extension of Time (three months, large entity) is enclosed, extending the date to April 8, 2005. A check including payment of the requisite fee also is enclosed. Therefore, please accept this Amendment as timely filed.

In response to the Office Action dated October 8, 2004, kindly amend the above-identified patent application as set forth below.